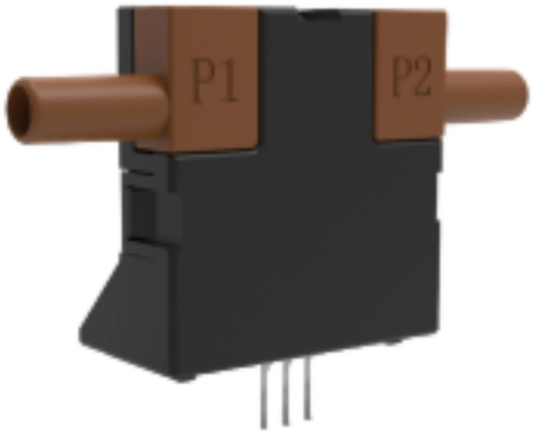
Wattwise Solutions LLC

Thermal MEMS flow sensors

WW-CMP-110



Thermal flow sensors combining a MEMS sensing chip, a molded bypass flow path and digital signal processing. The family provides linearized analog output and a rapid response for instrument and process monitoring. Full-scale flow is selected to match the measurement application.

Applications

• Analytical instrument flow monitoring

• Particulate monitoring instruments

• Industrial process flow

Technical data

Measurement method	MEMS
Measurement range	0–30 / 200 / 1000 / 20000 sccm
Response time	<50 ms
Interface	1–5 V
Power supply	7–15 V
Operating temperature	0–50 °C

Specifications vary with model and configuration. Contact Wattwise to confirm suitability, measurement ranges and available options for your project.
Manufacturer: Sheens